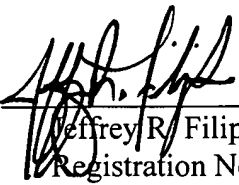


**REMARKS**

This Preliminary Amendment is presented in order to: (1) add identifying data to the top of page 1 of the specification and make a minor editorial amendment to the specification; (2) incorporate the changes made in the International Application under Article 34; and (3) cancel sheet 6/6 of the drawings, which contains only a list of the "Reference marks in the drawings."

Respectfully submitted,

Yuichiro SASAKI et al.

By   
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Reference marks in the drawings

- 
- 10 Reactor chamber
  - 20 Silicon wafer
  - 30  $B_2H_6$  gas
  - 40 ECR plasma source
  - 45 Plasma
  - 50 Wafer susceptor
  - 60 RF power supply
  - 100 Plasma doping apparatus
  - 101 High-frequency power supply
  - 102 Matching box
  - 103 Coil and antenna
  - 104 Mass-flow controller
  - 105 Mass-flow controller
  - 106 Turbo pump
  - 107 Conductance valve
  - 108 Dry pump
  - 109 Circulator
  - 110 DC power supply
  - 111 Matching box
  - 112 High-frequency power supply
  - 113 Target
  - 114 Susceptor
  - 115 Reactor chamber
  - 116 Glass member
  - 401, 402 Plotted line indicating the relation between  
voltage application time and sheet resistance